Form PTO-1449 (Modified)	Atty Docket No.	Serial No.		
LIGT OF DATENTS AND DUD ICATIONS	AVERP3071USA	10/734,379		
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S VINFORMATION DISCLOSURE STATEMENT	Applicant: Bharadwaj et al.			
(Use several sheets if necessary)	Filing Date 12/12/03	Group 1732		
U.S. PATENT D	OCUMENTS I Store	Sub-class Silies Date if		

TRANEN Examiner nitial	Document Number	Date (MMYYYY)	Name	Class	Sub-class	Filing Date if Appropriate
IV	4,332,847	6/1982	Rowland	428	156	
(-	4,478,769	10/1984	Pricone, et al.	264	1.6	
$\overline{}$	4,486,363	12/1984	Pricone, et al.	264	1.4	
	4,601,861	7/1986	Pricone, et al.	264	1.6	
	4,925,714	5/1990	Freedman	428	40	
7	5,945,042	8/1999	Mimura, et al.	264	1.6	
12	2004/0130057	7/2004	Mehrabi, et al.	264	171.13	

## FOREIGN PATENT DOCUMENTS

Examiner	Document Number	Date	Country	Class	Sub- class	Translation	
Initial		(MMYYYY)				Yes	No
N	101 20 269	7/2002	DE	-	_	X*	
10	01/98066	12/2001	WO		1		

\*Abstract Only

## OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
N	Pease, Fabian R. "Imprints offer Moore." in Nature (2002), Vol. 417, pp. 802-803.
14	Chou, Stephen Y., et al. "Ultrafast and direct imprint of nanostructures in silicon." in Nature (2002), Vol. 417, pp. 835-837.

	<del></del>	
EXAMINER	If deches of	DATE CONSIDERED , L/o y

**EXAMINER:** 

Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.